



2857
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Hubbard et al.	Examiner:	Wachsman, H.
Serial No.:	09/520,686	Group Art Unit:	2857
Filed:	March 7, 2000	Docket No.:	US 008023 (VLSI.413PA)
Title:	Wafer Target Design and Method for Determining Centroid of Wafer Target		

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence and the papers, as described hereinabove, are being deposited in the United States Postal Service, as first class mail, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on August 10, 2004.

By:

Katie Brandel
Katie Brandel

OFFICE ACTION RESPONSE AND AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the non-final Office Action dated May 14, 2004, please consider the following amendment and remarks.

Amendments to the Specification begin on page 2, amendments to the claims are reflected in the listing of claims beginning at page 3 and the Remarks begin on page 7.